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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Attorney Docket No.: 926530-96468 }
Applicants: *Shibata et al.* }
Serial No. 10/519,152 }
Filed: August 10, 2005 }
Examiner: *Cheung Lee* }
Title: *POROUS SUBSTRATE AND*
ITS MANUFACTURING
METHOD, AND GAN
SEMICONDUCTOR
MULTILAYER SUBSTRATE
AND ITS
MANUFACTURING
METHOD

Certificate Under 37 CFR 1.8(a)

I hereby certify that this correspondence is being electronically filed via EFS WEB addressed to: Mail Stop Petition, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on April 28, 2008.

Colleen M. Dunphy
Colleen M. Dunphy

Mail Stop Petition
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

- AUTHORIZATION TO PAY AND PETITION FOR THE ACCEPTANCE OF ANY NECESSARY FEES. If any charges or fees must be paid in connection with the following Communication (including but not limited to the payment of Issue Fees), they may be paid out of our Deposit Account No. 23-0920. If this payment also requires a Petition, please construe this authorization to pay as the necessary Petition which is required to accompany this payment.
- Applicant hereby petitions for a Three-month Extension of Time and entry of this Response to Restriction Requirement which is sent on April 28, 2008. The payment of \$2,690.00 for total cost of this filing is being paid by charge card.

RESPONSE TO RESTRICTION REQUIREMENT